

Electronic Acknowledgement Receipt

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International Application Number:	
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Title of Invention:	SEMICONDUCTOR FILM MANUFACTURING METHOD AND SUBSTRATE MANUFACTURING METHOD
First Named Inventor/Applicant Name:	Yoshinobu Sekiguchi
Customer Number:	5514
Filer:	Damond Edward Vadnais
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Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Foreign Reference	TW_558743.pdf	3157069	no	93
			aa5bb6795c7c6a3ac12ace3419f28419527c4d94		
Warnings:					
Information:					
2	NPL Documents	TW_Official_Action.pdf	848529	no	23
			174fcc8e2c7585d5f759f276a289e36370b850eb		
Warnings:					
Information:					
3	Foreign Reference	TW_I284360.pdf	1912747	no	54
			e70c24735effb9702f0c7eb1d4aa541b332221f		
Warnings:					
Information:					
4	NPL Documents	Xiao_Intro_Semiconductor_Mfg_Tech_2001_p603.pdf	208079	no	2
			b5769108229481060a6b13f06caca29618cccf9		
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5	Information Disclosure Statement (IDS) Filed	IDS_00862_109138.pdf	784408	no	4
			33072553441d2fceddfe6b2a34e42a3de0c193a		
Warnings:					
Information:					
6	Fee Worksheet (PTO-06)	fee-info.pdf	8236	no	2
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